



Docket No. 740819-725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of:

Yasutoshi OKUNO et al.

Application No. 10/032,564

Filed: January 2, 2002

For: METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE

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-) Group Art Unit: 2823
-) Examiner: Michelle Estrada
-) Confirmation No. 5824
-) Date: March 19, 2004

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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AMENDMENT

Mail Stop AF
Commissioner for Patents
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Sir:

In response to the Office Action mailed December 24, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.